



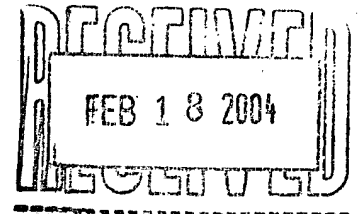
PATENT  
97-CT-174

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
RAFFAELE ZAMBRANO )  
Serial No.: 09/191,743 )  
Filed: November 13, 1998 )  
For: IN-SITU DEPOSITION AND )  
DOPING PROCESS FOR POLY- )  
CRYSTALLINE SILICON LAYERS )  
AND THE RESULTING DEVICE )

Group Art Unit: 2823

Examiner: M. Estrada



PETITION FOR EXTENSION OF TIME

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:


In accordance with Rule 1.136, Applicant respectfully petitions the Commissioner for an extension of time extending to February 2, 2004, the period for response to the Office Action dated August 1, 2003. Please charge the amount of \$950.00 for the extension fee to Deposit Account No. 50-1556. The responsive paper is attached.

If it should be determined that a longer extension is required to prevent this application from becoming abandoned, or for any other reason an insufficient fee has been paid, please charge any insufficiency to Deposit Account No. 50-1556.

02/13/2004 CNGUYEN 00000003 501556 09191743  
01 FC:1253 950.00 DA

Respectfully submitted,

Date: February 2, 2004

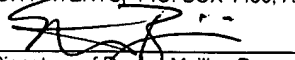
By:   
Stephen Bongini  
Registration No. 40,917

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GUTMAN & BONGINI P.L.  
One Boca Commerce Center  
551 Northwest 77th Street, Suite 111  
Boca Raton, Florida 33487  
Telephone: (561) 989-9811

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450.

  
Name of Person Mailing Paper

  
Signature of Person Mailing Paper

2/2/04  
Date of Deposit